



IFW

Applicant: Pei-Yang Yan

Serial No.: 10/631,171

Filed: July 31, 2003

For: Multilayer Reflective Extreme
Ultraviolet Lithography Mask
Blanks

§ Group Art Unit: 1756

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§ Examiner: Stephen D. Rosasco

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§ Atty. Dkt. No.: ITL.0952US
(P15976)

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicant submits the references listed on the attached form PTO 1449, copies of which are enclosed. A copy of a communication dated June 27, 2005 from a foreign patent office in a counterpart application is also enclosed. I, the undersigned, hereby certify that each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement. Please apply any charges or credits to Deposit Account No. 20-1504 (ITL.0952US).

Respectfully submitted,

July 6, 2005

Date

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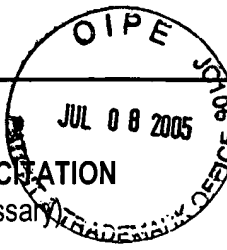
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Monica Jacobs



"INFORMATION DISCLOSURE CREATION
(Use several sheets if necessary)

ATTY DOCKET NO.
ITL.0952US (P15976)

SERIAL NO.
10/631,171

APPLICANT(S):
Pei-Yang Yan

FILING DATE:
July 31, 2003

GROUP ART UNIT:
1756

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A.						
	B.						
	C.						
	D.						
	E.						

U.S. PATENT APPLICATION PUBLICATIONS

	F.	US 2003/0008180	01/09/2003	Bajt et al.			
	G.	US 2003/0031937	02/13/2003	Yan			
	H.	US 2003/0123605	07/03/2003	Rau			
	I.	US 2004/0002009	01/01/2004	Yan			
	J.						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	K.	EP 1 065 568	01/03/2001	Europe				
	L.	EP 1 394 815	03/03/2004	Europe				
	M.	JP 2003-249434	09/05/2003	Japan			Abstract Only	
	N.							
	O.							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	P.	M. Singh et al., <i>Capping Layers For Extreme-Ultraviolet Multilayer Interference Coatings</i> ; Optics Letters, Optical Society of America, Washington, Vol. 26, No. 5, March 1, 2001, pgs. 259-261.
	Q.	
	R.	
	S.	
	T.	
	U.	
	V.	

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.